

AMENDMENT TRANSMITTAL LETTERDocket No.
12088/019001Application No.
10/500,317-Conf. #9863Filing Date
June 28, 2004Examiner
R. ZervigonArt Unit
1792

Applicant(s): Shinichi Kawasaki et al.

Invention: PLASMA FILM FORMING SYSTEM

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED						
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate		
Total Claims	10	- 59 =	0	x	50.00	0.00
Independent Claims	1	- 3 =	0	x	210.00	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>						
Other fee (please specify):						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:						0.00

☒ Large Entity☐ Small Entity☒ No additional fee is required for this amendment.☐ Please charge Deposit Account No. _____ in the amount of \$ _____.
A duplicate copy of this sheet is enclosed.☐ A check in the amount of \$ _____ to cover the filing fee is enclosed.☐ Payment by credit card.☒ The Director is hereby authorized to charge and credit Deposit Account No. 50-0591
as described below. A duplicate copy of this sheet is enclosed.☒ Credit any overpayment.☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17./Jonathan P. Osha/
Jonathan P. Osha
Attorney/Agent Reg. No.: 33,986

Dated: August 4, 2008

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Docket No.: 12088/019001
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Shinichi Kawasaki et al.

Application No.: 10/500,317

Confirmation No.: 9863

Filed: June 28, 2004

Art Unit: 1792

For: PLASMA FILM FORMING SYSTEM

Examiner: R. Zervigon

REPLY UNDER 37 C.F.R. § 1.111

Ms Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated May 2, 2008, please reconsider this application in view of the following.